

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10019407
<b>Filing Date:</b>	25-Mar-2002
<b>Title of Invention:</b>	POLYSILICON SEMICONDUCTOR THIN FILM SUBSTRATE, METHOD FOR PRODUCING THE SAME, SEMICONDUCTOR DEVICE, AND ELECTRONIC DEVICE
<b>First Named Inventor/Applicant Name:</b>	Yoshinobu Kimura
<b>Filer:</b>	Larry Naoum Anagnos/Donald Prater
<b>Attorney Docket Number:</b>	520.41003 X00

Filed as Large Entity

### **U.S. National Stage under 35 USC 371 Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
Utility Appl issue fee	1501	1	1510	1510
<b>Extension-of-Time:</b>				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Printed copy of patent - no color	8001	4	3	12
<b>Total in USD (\$)</b>				<b>1522</b>